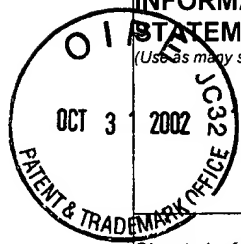


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**Application Number** 09/712795  
**Filing Date** November 14, 2000  
**First Named Inventor** Craighead, Harold  
**Group Art Unit** 2878  
**Examiner Name** Chu, Changhwa

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Attorney Docket No: 01153.010US1

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Examiner Initials *	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
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*C. Chu*

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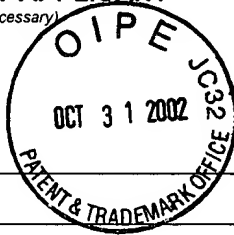
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